

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideaki Kuwabara et al.

Art Unit : Unknown

Serial No. : 10/735,767

Examiner : Unknown

Filed : December 16, 2003

Title : SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

**MAIL STOP AMENDMENT**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

This statement is being filed before the receipt of a first Office Action on the merits.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: April 11, 2005

  
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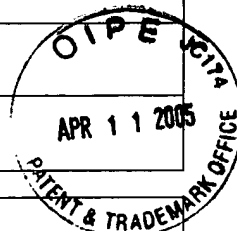
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Substitute Form PTO-1449 (Modified)  <b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)  (37 CFR §1.98(b))	U.S. Department of Commerce Patent and Trademark Office		Attorney's Docket No. 12732-189001	Application No. 10/735,767
	Applicant Hideaki Kuwabara et al.			
	Filing Date December 16, 2003		Group Art Unit	



### U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2003-0025118	02/06/2003	YAMAZAKI et al.			07/22/2002
	AB	2003-0032210	02/13/2003	TAKAYAMA et al.			07/15/2002
	AC	2003-0047280	03/13/2003	TAKAYAMA et al.			08/14/2002
	AD	2003-0064569	04/03/2003	TAKAYAMA et al.			08/09/2002
	AE	2003-0082889	05/01/2003	MARUYAMA et al.			10/30/2002
	AF	2003-0217805	11/27/2003	TAKAYAMA et al.			05/16/2003
	AG	2004-0087110	05/06/2004	TAKAYAMA et al.			07/15/2003
	AH	2004-0121516	06/24/2004	YAMAZAKI et al.			12/08/2003
	AI	2004-0140547	07/22/2004	YAMAZAKI et al.			12/09/2003
	AJ	2004-0232413	11/25/2004	YAMAZAKI et al.			10/29/2003
	AK						

### Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	AL	JP2000-061785	29 FEB 2000	JAPAN			Abstract	
	AM							
	AN							
	AO							
	AP							

### Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	